



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 19, 2025

IGI Report Number **LG758561400**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.76 - 8.79 X 5.29 MM**

**GRADING RESULTS**

Carat Weight **2.50 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

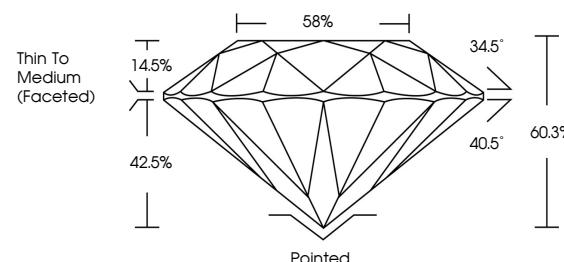
Inscription(s) **IGI LG758561400**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

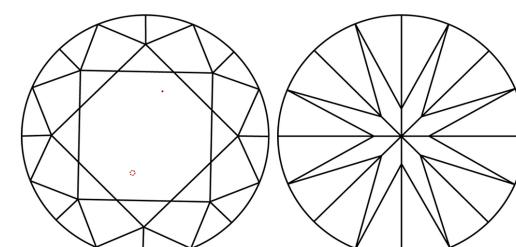
Type Ila

LG758561400  
Report verification at [igi.org](https://igi.org)

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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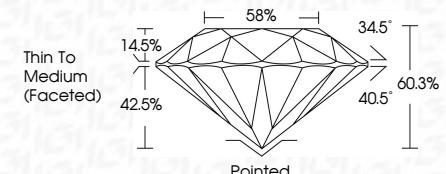
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Sample Image Used



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Clarity Grade	<b>VVS 2</b>	Symmetry	<b>EXCELLENT</b>
Cut Grade	<b>IDEAL</b>	Fluorescence	<b>NONE</b>
Depth	60.3%	Inscription(s)	<b>IGI LG758561400</b>
Table	40.5%		
Girdle	14.5%		
Culet	58%		
Polish	Thin To Medium (Faceted)		
Symmetry	Pointed		
Fluorescence			
Inscription(s)			

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